	Type	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
1	BRS	848	abrasive with ((first and second) adj3 (material or layer or coat$3 or cover$3))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/10 13:28			0
2	BRS	130	(abrasive with ((first and second) adj3 (material or layer or coat$3 or cover$3))) and (cmp or ("chemical mechanical" adj (polish$3 or planariz$5)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/10 13:29			0
3	BRS	74	((abrasive with ((first and second) adj3 (material or layer or coat$3 or cover$3))) and (cmp or ("chemical mechanical" adj (polish$3 or planariz$5)))) and @pd<=20020926	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/10 13:30			0
4	BRS	0	(abrasive with nanoporous) same (cmp or ("chemical mechanical" adj (polish$3 or planariz$5)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/10 15:09			0
5	BRS	2	(abrasive with nanoporous) and (cmp or ("chemical mechanical" adj (polish$3 or planariz$5)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/10 15:11			0
6	BRS	5	((abrasive or particle$s) with nanoporous) and (cmp or ("chemical mechanical" adj (polish$3 or planariz$5)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/10 15:17			0
7	BRS	3	(((abrasive or particle$s) with nanoporous) and (cmp or ("chemical mechanical" adj (polish$3 or planariz$5)))) not ((abrasive with nanoporous) and (cmp or ("chemical mechanical" adj (polish$3 or planariz$5))))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/10 15:12			0
8	BRS	5	((abrasive or particle$s or slurry) with nanoporous) and (cmp or ("chemical mechanical" adj (polish$3 or planariz$5)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/10 15:17			0